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VU, Quang D
EXAMINER

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STATEMENT BY APPLICANT

MAY 02 2003

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
qV	AA	6,064,081	05/16/2000	Robinson et al.			01/15/1998
qV	AB	5,760,443	06/02/1998	McCarthy			10/23/1995
qV	AC	5,629,790	05/13/1997	Neukermans et al.			10/18/1993
qV	AD	4,614,119	09/30/1986	Zavracky et al.			03/08/19985
	AE						
	AF						

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
qV	AG	2,275,787	09/07/1994	UK			YES
	AH						
	AI						

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER INITIAL		
qV	AJ	"Evaluation of Wafer Bonding and Etch Back for SOI Technology," Baumgart et al. <i>Philips Journal of Research</i> . 1995. Vol. 49, No. ½.
qV	AK	"Micromachined Widely Tunable Vertical Cavity Laser Diodes," Sugihwo et al. <i>Journal of Microelectromechanical Systems</i> . March 1998. Vol. 7, No. 1.
	AL	
	AM	
	AN	
	AO	

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